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Sheet 1 of 1

Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 128620		APPLICATION NO. 10/584,950	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)							
				APPLICANT Hiroyuki NAGASAKA			
				FILING DATE July 5, 2006		GROUP 2851	
U.S. PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Name			
	1	2005/0179877 A1	08/18/2005	MULKENS et al.			
	2	2005/0018155 A1	01/27/2005	COX et al.			
FOREIGN PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation	
	3	EP 1 524 558 A1	04/20/2005	Europe			
	4	EP 1 498 778 A1	01/19/2005	Europe			
	5	EP 1 528 433 A2	05/04/2005	Europe			
	6	WO 2004/093160 A2	10/28/2004	WIPO			
OTHER DOCUMENTS							
Examiner Initials	Cite No.	Including name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.					
	7	OWA et al., "Immerson Lithography; its potential performance and issues", Proceedings Of Spie, 28 February 2003, pages 724-733, vol. 5040, no. 1, BELLINGHAM, VA.					
EXAMINER				DATE CONSIDERED			
/Peter Kim/				08/04/2009			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: September 17, 2008

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /P.K./